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## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re PATENT APPLICATION OF

Inventor(s): SHINRIKI, Hiroshi et al

Filed: Herewith

Title: FILM DEPOSITION APPARATUS AND METHOD

April 24, 2001

CA  
AH  
11/21/01PRELIMINARY AMENDMENTHon. Commissioner of Patents  
Washington, D.C. 20231

Sir:

Please amend this application as follows:

IN THE SPECIFICATION:

At the top of the first page, just under the title, insert

☒ --This application is the National Phase of International Application  
PCT/JP00/05858 filed August 30, 2000 which designated the U.S.

and that International Application

☒ was ☐ was not published under PCT Article 21(2) in English.--

Respectfully submitted,

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